

Shimadzu LabSolutions GC System Configuration

<<Instrument>>

Instrument Name : GC1
 Instrument Type : GC
 Communication : GC GC-2010 RS232C COM1

<<GC>>

[GC General]

=General=

of Analytical Lines : 1 Gas Pressure Unit : kPa
 Save the Status Monitor : Yes Sampling Period : 1 sec
 Atmosphere Compensation : No
 GC System On When turning on the power : No
 (System On/Off Parameters)
 Start Time : 0.0 min Stop Time : 0.0 min
 Sleep Time : No Flow Off Time : No
 System On Mode : Flow/Temp>Det

=CRG/Relays=

CRG-Column Oven : None CRG-INJ2 : None
 OCI/PTV Fan : None
 Relay 1-16 : None Relay 1-10,93,94 : None

=Device Information=

Serial Number : C11323800691
 ROM Version : 1.1180
 Unit ID :

[Line Configuration]

=Analytical Line 1=

(Auto Sampler)

Type : AOC-20i Rack Type : Short
 Vial Capacity : 1.5 mL Syringe Capacity : 10 uL
 Device Information
 Serial Number :
 ROM Version : 1.60
 Unit ID :

(Injection Port)

Name : SPL
 Injection Unit Type : SPL Carrier Gas : He
 Heater
 Zone : INJ1 Max Temp : 470.0 C
 Carrier Flow
 Flow Unit Type : AFC-2010
 Zone : CAR1 Slot : SLOT1
 Primary Pressure : 500.0-900.0 kPa
 Septum Used Counts : 100
 Insert Used Counts : 100

(Column)

Name : Stabilwax
 Column ID :
 Film Thickness : 0.50 um Length : 30.0 m
 Inner Diameter : 0.32 mm Max Usable Temp : 260 C
 Activation Date : 4/8/2009
 Description :

(Detector ch1)

Name : FID1
 Detector Type : FID Det# : DET#4
 Base Period : 40 msec
 Filter Time Const. : 200 msec
 Heater
 Zone : DET1 Max Temp : 470.0 C
 Flow
 Detector APC Type : APC(Det3ch)
 Zone : DetAPC1 Slot : SLOT3
 Makeup Gas Type : He

[Additional Heater]

[Additional Flow]